

PATENT ASSIGNMENT

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SUBMISSION TYPE:	NEW ASSIGNMENT												
NATURE OF CONVEYANCE:	EXECUTIVE ORDER 9424, CONFIRMATORY LICENSE												
CONVEYING PARTY DATA													
<table border="1"><tr><th>Name</th><th>Execution Date</th></tr><tr><td>California Institute of Technology</td><td>11/04/2010</td></tr></table>	Name	Execution Date	California Institute of Technology	11/04/2010									
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California Institute of Technology	11/04/2010												
RECEIVING PARTY DATA													
<table border="1"><tr><td>Name:</td><td>National Science Foundation</td></tr><tr><td>Street Address:</td><td>4201 Wilson Blvd</td></tr><tr><td>Internal Address:</td><td>Room 1265</td></tr><tr><td>City:</td><td>Arlington</td></tr><tr><td>State/Country:</td><td>VIRGINIA</td></tr><tr><td>Postal Code:</td><td>22230</td></tr></table>	Name:	National Science Foundation	Street Address:	4201 Wilson Blvd	Internal Address:	Room 1265	City:	Arlington	State/Country:	VIRGINIA	Postal Code:	22230	
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Application Number:	12626239												
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Total Attachments: 1 source=87#page1.tif													

License to the United States Government

Invention Title: Method and Apparatus for Controlled Fabrication of Micro and Nanoscale Structures by Thermocapillary Lithography

Inventors: Sandra M. Troian

Patent Application Serial No: 12/626,239

US Filing/Issue Date: 11/25/2009

Grant/Contract Identification No: CTS0649474

Foreign Applications filed/intended in (countries):

The invention identified above is a Subject Invention under 35 U.S.C. 200, et seq., and the Standard Patent Rights clause at 37 CFR 401.14 or FAR 52.227-11, which are included among the terms of the above-identified grant/contract award from the National Science Foundation. This document is confirmatory of:

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The Government is hereby granted an irrevocable power to inspect and make copies of the above-identified patent application.

California Institute of Technology
1200 E. California Boulevard
Pasadena, California 91125

Dated: November 4, 2010



Fred Farina, Asst VP for Tech Transfer

CIT File No: 5269